

REQUEST FOR CORRECTED FILING RECEIPT

Applicant : Hirayama et al.

Appl. No. : 10/590,046

Filed : June 15, 2007

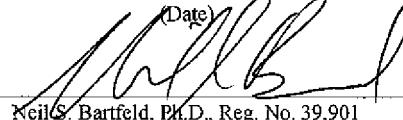
For : BASE MATERIAL FOR
 PATTERN-FORMING MATERIAL, POSITIVE
 RESIST COMPOSITION AND METHOD OF RESIST
 PATTERN FORMATION

Art Unit : 1752

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June 4, 2008



(Date)
 Neil S. Bartfeld, Ph.D., Reg. No. 39,901

Commissioner for Patents
 P.O. Box 1450
 Office of Initial Patent Examination
 Customer Service Center
 Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby request that the Official Filing Receipt, a copy of which is enclosed, be corrected to reflect the title, BASE MATERIAL FOR PATTERN-FORMING MATERIAL, POSITIVE RESIST COMPOSITION AND METHOD OF RESIST PATTERN FORMATION. Presently, the Filing Receipt incorrectly shows the title as BASE MATERIAL FOR PATTERN-FORMING MATERIAL, POSITIVE RESIST COMPOSITION AND METHOD OF RESIST FORMATION.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 6/4/08By: 

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 Registration No. 39,901
 Agent of Record
 Customer No. 20,995
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APPLICATION NUMBER	FILING or 371(c) DATE	GRP ART UNIT	FIL FEE RECD	ATTY/DOCKET NO	TOT CLAIMS	1ND CLAIMS
10/590,046	06/15/2007	1752	1030	SHIGA7.055APC	15	2

CONFIRMATION NO. 5635

20995
KNOBBE MARTENS OLSON & BEAR LLP
2040 MAIN STREET
FOURTEENTH FLOOR
IRVINE, CA 92614

FILING RECEIPT



OC000000D25610338

Date Mailed: 02/15/2008

Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections.

Applicant(s)

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Power of Attorney: The patent practitioners associated with Customer Number 20995

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP05/01798 02/08/2005

Foreign Applications

JAPAN 2004-045043 02/20/2004
JAPAN 2004-045044 02/20/2004
JAPAN 2004-182300 06/21/2004
JAPAN 2004-182301 06/21/2004

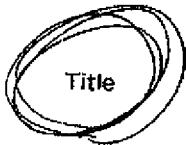
If Required, Foreign Filing License Granted: 08/29/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US 10/590,046

Projected Publication Date: Not Applicable

Non-Publication Request: No

Early Publication Request: No



Base Material for Pattern Forming Material, Positive Resist Composition and Method of Resist Formation

Preliminary Class

430

Pattern

PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process ~~simplifies~~ the filing of patent applications on the same invention in member countries, but ~~does not result in~~ a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

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